Comparison of SPAD, SiPM and APD performance for dToF LiDAR application

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Direct ToF LiDAR – Simple Concept

• Single Shot laser pulse & photon arrival timestamp for Depth measurement



• Multi Shot laser pulses & photon arrival timestamps to calculate Depth from histogram







Typical photon detectors for LiDAR

Avalanche	Single Photon Avalanche Diode arrays (SPAD arrays)	Silicon			APD	SPAD		SiPM
Photodiodes (APD)		Photomultipliers (SiPM)	PDE @ 905 nm		N/A	30%		
			QE @ 905 nm		55%	N/A		
 K High Voltage X Poor Uniformity ✓ Moderate Gain (10²) !! Linear Mode Market Adoption 	 Low Voltage Excellent Uniformity Very High Gain (10⁶) Geiger Mode – Single Photon Market Adoption 	 Low Voltage Excellent Uniformity Very High Gain (10⁶) Geiger Mode – Multi-Photon Market Adoption 	N _{pixels}		N/A	2×2	7×7	2400
			т _{dead} ns		N/A	6		14
			Р _{хт} %		N/A	1		15
			DCR MHz/mm²	25 C	N/A	0.025		0.15
				105 C		2	25	150
			F		4	1.01		1.19
			R₀ A/W M or G		0.4	N/A		
					100	1E5		
				25 C	0.05	N/A		
			I _D , NA	105 C	102	N/A		

Calculations were performed for APD, SiPM and SPAD array (w/ 2x2 & 7x7 SPAD's per macro-pixel) at 25 °C & 105 °C



LiDAR typical system specification:



Calculations were performed for short & long range 905nm LiDAR`s, with different FoV and resolution



Some Initial Model Considerations

- Model assumptions:
 - Single point LiDAR
 - Lambertian target;
 - Laser spot:
 - within the sensor AoV;
 - Smaller than the target;
 - Ambient light power of 100 kLux
- Return laser power: $P_{S}(d) = P_{laser} \cdot \varepsilon_{RX} \cdot \varepsilon_{TX} \cdot \frac{1}{2\pi d^{2}} \times \eta \times A_{aperture}$
- Background optical power:
 - $P_B = \frac{1}{2\pi \cdot d^2} \cdot \Phi_{amb} \cdot A_{FoV} \cdot \eta \cdot \varepsilon_{RX} \cdot A_{aperture}$
- Aperture:

$$A_{aperture} = \pi \frac{D_{lens}^2}{4}$$









Aperture & Rx lens diameter D_{lens}

Return laser power:

$$P_{S}(d) = P_{laser} \cdot \varepsilon_{RX} \cdot \varepsilon_{TX} \cdot \frac{1}{8d^{2}} \times \eta \times D_{lens}^{2}$$

Background optical power:

$$P_B = \frac{1}{8 \cdot d^2} \cdot \Phi_{amb} \cdot A_{FoV} \cdot \eta \cdot \varepsilon_{RX} \cdot D_{lens}^2$$

- Lens diameter *D_{lens}* defined the return laser power and collected ambient light;
- It should be optimized for each particular case:
 - Laser power;
 - Filter width;
 - Sensor performance;
 - Ranging;
 - etc.



Figure 1 Return laser power (expressed in percentage and watts for initial laser power of 150, 100, 50 and 10 W) as a function of background light power (expressed in watts and photons per second) for 905 and 1550 nm systems. Results presented at different Dlens and AoV values and for two target distances of 200 m and 50 m.

SNR calculations:



$$SNR_{APD} = \sqrt{N_{shots}} \frac{R_0 \times P_S}{\sqrt{2eB_N \times F \times (R_0 \cdot P_B + I_D) + \frac{B_N}{M^2} \left(\frac{4k_BT}{R_f} + \frac{\langle V_{amp} \rangle^2}{R_f^2}\right)}}$$

where:

APD:

- *R*₀ is responsivity without multiplication;
- *F* is excess noise factor;
- I_D is dark current, $I_D(T) = I_D(25^{\circ}\text{C}) \times 1.1^{T 25^{\circ}\text{C}}$
- *M* is multiplication factor or Gain;
- *T* is temperature in K,
- <V_{amp}> is amplifier input voltage noise density;
- R_f is feedback resistance

SiPM & SPAD:



$$SNR = \sqrt{N_{shots}} \frac{N_{laser}}{\sqrt{N_{amb} + N_{elec.}^2}}$$

where:

$$N_{amb} = N_{cells} \cdot \left(1 - e^{-\left(\frac{P_B}{hc_{\lambda}}, PDE + DCR\right) \frac{\tau_{dead}}{N_{cells}/(1 - \langle XT \rangle)}} \right)$$

•
$$N_{laser} = (N_{cells} - N_{amb}) \times \left(1 - e^{-\left(\frac{P_S}{hc_{\lambda}} \cdot PDE + DCR\right) \frac{t_{laser}}{N_{cells}/(1 - \langle XT \rangle)}}\right)$$

- $N_{elec.}^2 = \left(\frac{\tau_{dead}}{e \times G}\right)^2 \times B_N \times \left(\frac{4k_BT}{R_f} + \frac{\langle V_{amp} \rangle^2}{R_f^2}\right)$
- *PDE* is SiPM or SPAD photon detection efficiency;
- τ_{dead} is dead time;
- N_{cells} is number of microcells,
- *DCR* is dark count rate, $DCR(T) = DCR(25^{\circ}C) \times 2^{T-25^{\circ}C/_{8^{\circ}C}}$
- $\langle XT \rangle = -ln(1 P_{XT})$ is an average number of crosstalk events per single avalanche, P_{XT} is optical crosstalk probability

SNR calculations: validation



Single point Lidar







SNR results: from perfect to real sensor





SNR results: APD vs. SiPM vs. SPAD @ 25 °C



Detector Internal Noise ↗

Detector Dynamic Range ↗

Onsemi

SNR results: APD vs. SiPM vs. SPAD @ 105 °C



Detector Internal Noise ↗

Detector Dynamic Range ↗

Onsemi

SNR vs. D_{lens}:



APD based system:

- Better performance with high D_{lens}
- High SNR fluctuation with T due to dark current

SiPM based system:

- Good performance over different D_{lens}
- SNR fluctuation with T due to DCR

SPAD based systems:

- Better performance at low D_{lens}
- No SNR fluctuation with T due to low DCR



Effect of Read-out Electronics on SNR



 B_N is defined as the frequency at which the gain of the amplifier becomes 0 dB; $Noise^{2} = \frac{B_{N}}{M^{2}} \left(\frac{4k_{B}T}{R_{f}} + \frac{\langle V_{amp} \rangle^{2}}{R_{f}^{2}} \right) - \left\{ V_{amp} \right\}$ is amplifier input voltage noise density; • $\left\langle V_{amp} \right\rangle$ is feedback resistor which set the gain of the transimpedance amplifier;



Due to much higher internal gain (i.e. 10⁵ - 10⁶) SiPM or SPAD devices less sensitive to electronics noise with respect to APDs which Gain (or multiplication ~ $10^2 - 10^3$) is limited by dark current

Conclusions:

- To realize all the advantages the SiPM or SPAD could provide, the optical system should be designed to suppress unwanted interference from ambient background light (i.e. small D_{lens} and FoV);
- Due to relatively small internal multiplication *M*, the choice of read-out electronics is critical for APD-based LiDAR system, while SiPM & SPAD-based systems could tolerate much higher electronics noise due to high internal *Gain*
- SPAD vs. SiPMs \rightarrow smaller number of micro-cells leads:
 - ☺ to smaller DCR as a result better sensitivity to return laser light ;
 - ⓒ smaller SNR variation with temperature;
 - bigher device nonlinearity and sensitivity to ambient light;
- "Smart" SiPM device:

the possibility to activate (e.g. at high ambient or low T) or deactivate (e.g. at low ambient or high T) unused micro-cells on the fly will increase the LiDAR performance, and mitigate its performance degradation at high temperature.